

Advancement and Innovation for Detectors at Accelerators

# WP10 - status report



### Marcel Vos (IFIC – UVEG/CSIC – Valencia), Massimo Angeletti (CERN), Paolo Petagna (CERN)

With inputs from all WP10 groups

AIDAinnova 3rd annual meeting, Catania, March 21st



This project has received funding from the European Union's Horizon 2020 research and innovation programme under grant agreement No 101004761.



Advancement and Innovation for Detectors at Accelerators

### WP10 parallel session, with reports from all groups:

https://indico.cern.ch/event/1307202/sessions/502041/#20240320

Thanks to all speakers for their contributions, and for providing summary slides



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Advancement and Innovation for Detectors at Accelerators

WP10 goal: make sure that support, cooling and services do not limit the material budget of the next generation of vertex detectors and silicon trackers

### 20 years ago:

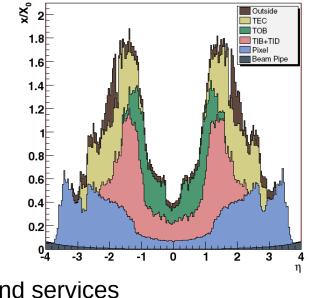
Full rad-hard, high-rate pixel+strip system ~0.4-1.8  $X_0$ Note: Silicon contributes: 10 x 2 x 300  $\mu$ m ~ 0.06  $X_0$ 

# Today:

WP5&6: active Silicon reduced to < 50  $\mu$ m/layer Can we reduce all non-active material too?

### The answer has to be yes, but this requires work on:

- new coolants and new cooling concepts
- novel materials/techniques
- further integration of active material, support, cooling and services
- more precise characterization of thermo-mechanical performance



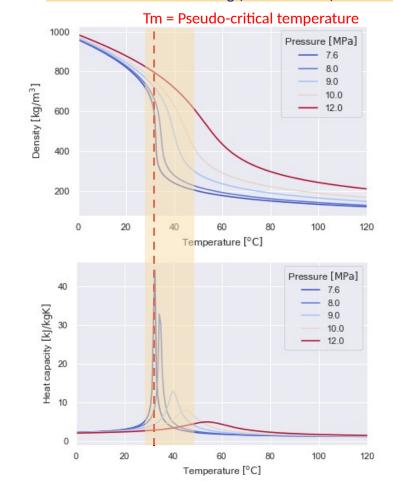
Tracker Material Budget





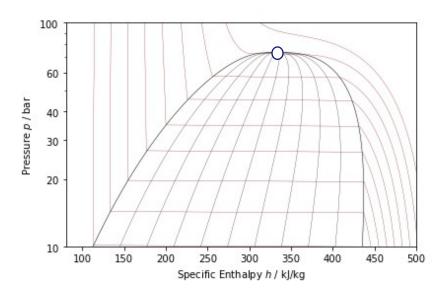
# Super-critical coolants (CERN)

Temperature of interest for room temperature detector cooling (+31 to +45 °C)



### Above critical value: change is continuous

- T<Tc liquid-like fluid
- T>Tc vapor-like fluid
- Critical point of carbon dioxide: 74 bar, 31 °C
- Super-critical Krypton possible ultra-cold solution



#### Supercritical refrigerants for detector applications

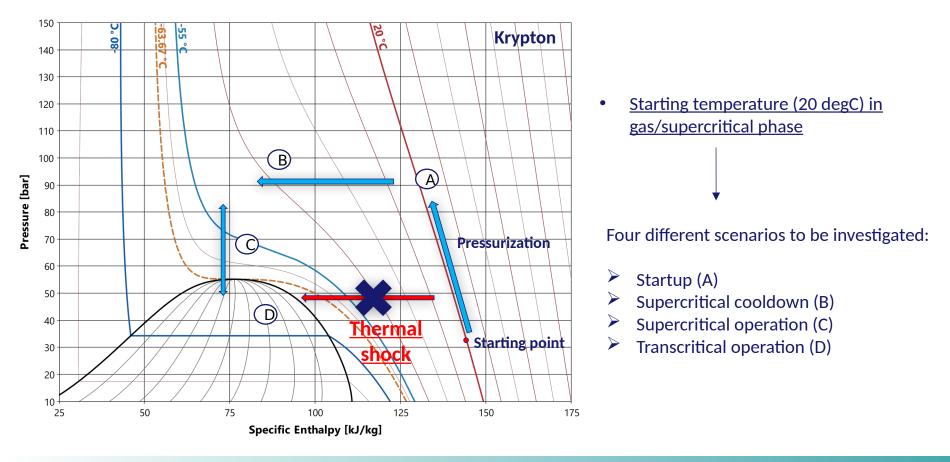
# **Status of CERN test rig**





# Super-critical Krypton (L. Contiero)

- Challenges with Krypton cooling: start cooling cycle without thermal shock
- Conceptual solution developed, tests foreseen



# Status of test rig (C. Pedano, CERN)





# WP10.2: Ultra-light and 3D-printed structures with integrated cooling

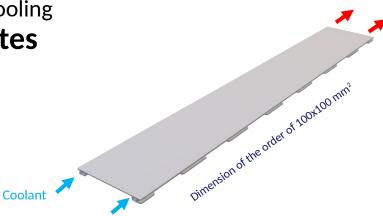
Ultra-light structures with integrated cooling
Carbon cold plate with embedded Kapton pipe

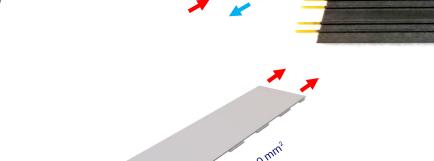
### **Purpose:**

- Technology compatibility with high-pressure boiling coolants.
- Produce large surfaces cold plate (CP) for high-pressure boiling coolants.
  - i.e. evaporative CO<sub>2</sub> and new coolants (Krypton, ...)
- 3D-printed structures with integrated cooling AM Ceramic & Metal cold plates

### **Purpose:**

 Generation of new standards to produce micro-structured cold plates produced by additive manufacturing, (ultra-thin wall).







# Carbon cold plate with polyimide pipes

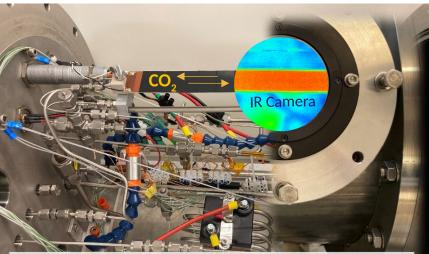
 Achievement: Established low-mass cold plate design with embedded Kapton pipes adapted and tested successfully <u>with evaporative CO<sub>2</sub></u> CERN EP R&D WP4

### D. Hellenschmidt M. Angeletti

Article under internal review: On-detector cooling systems based on low-mass carbon dioxide evaporators: cold plates with embedded Kapton tubes (D. Hellenschmidt, ...)



### **Experimental setup**



Experimental setup for detector cooling R&D with mini- and micro-scale carbon dioxide evaporators at CERN <u>http://cds.cern.ch/record/2748428</u>



# Carbon cold plate with polyimide pipes

- Know-how transferred to Workshape industrial partner ONGOING: 1.5m cold plate production (ITS2 like)
- Issues reproducing ALICE cold plates due to resin differences
- Cold plates manufacturing by end of April 2024.

**NEXT:** 1.5m cold plate (High-pressure resistance)



**CERN Knowledge Transfer** 







# Task10.2b AM (micro)channel cooling technology

### **3D integrated cooling circuits**

wall thickness for Al alloy

• 160 um 1/8" pipe

106 W

• 190 um 1/16" pipe

Investigation on the smallest leak-tight

106 W

#### • 1/16 pipe 240.0 (m)<sup>220,0</sup> 200.0 180,0 180,0 180,0 180,0 140,0 120.0 100 102 104 106 108 Laser power (W)

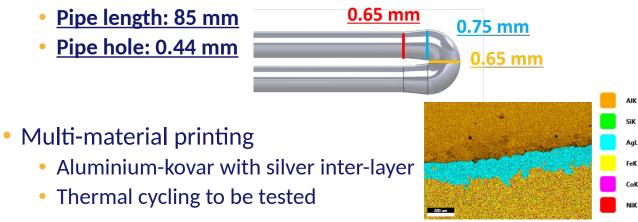
### **Updates: CSEM**

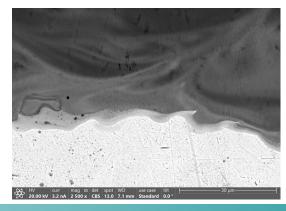
1/8 pipe

•The printing limits of AlSi12 material have been thoroughly understood.

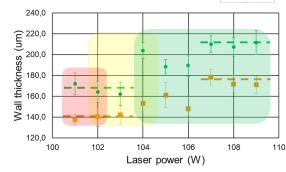
•KOVAR powder has been purchased; and printing capabilities with KOVAR material is currently under study.

Investigation on the smallest 180° curvature design size to remove powder





**# CSem** 





## Task10.2b AM (micro)channel cooling technology

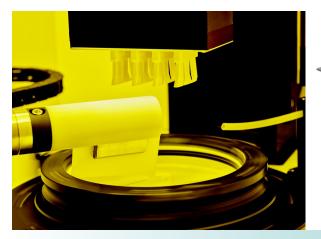
### **3D integrated cooling circuits in the structure**

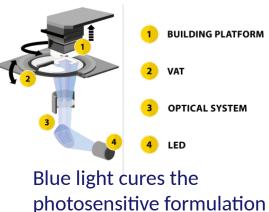
### Materials and technologies:

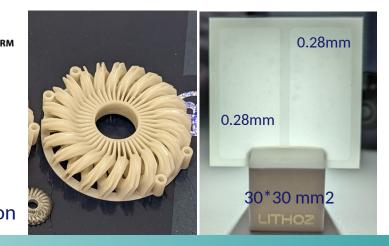
- **AM:** Lithography-based Ceramic Manufacturing (LCM) technology.
- **Ceramics:** Aluminum oxide (Al2O3), ONGOING: Aluminum nitride (AlN), Polymer-Ceramic composites.
- Aim: Define the optimal geometrical features attainable e.g. Minimum achievable wall thickness of pipes/plates, Flatness optimization (Firing step, 1500-2000 C, warping effect).

### **Updates: Lithoz**

- •The printing limits of Al2O3 material have been thoroughly understood.
- •Additional samples in AIN are in production for future irradiation test campaign.
- •Optimization of cold plate flatness investigation currently on going











# Task10.2b (micro)channel cooling

### Analysis, experimental tests:

Metrology, mechanical characterization tests (CERN)

•Geometrical limits for AlSi12, Al2O3 and AlN have been identified.

 First irradiation campaign and characterization tests completed for Al2O3 and AlN. No relevant changing in material properties (thermal

conductivity, Flexural modulus/strength) have been noticed.



Material properties investigation



Aluminium cradle for

Irradiation test campaign Non- and

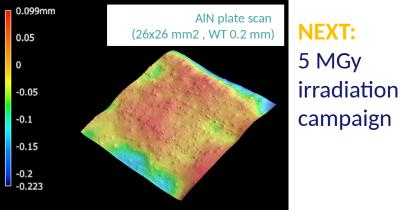
Irradiated samples (3,9 MGy)

#### AIN. OD 3.2 mm. WT 0.3 mm

**Updates: CERN** 



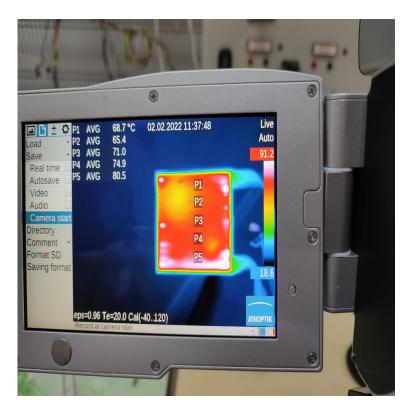
#### Metrology





WP10 Activities at INFN Cool FPGA (F. Palla, Pisa)

# Pyrex (300 µm)+ Silicon sandwich, glue Masterbond EP30TC





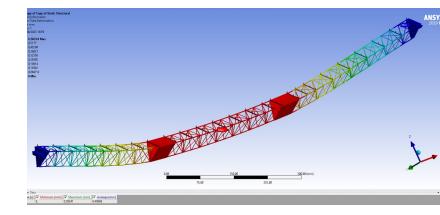
Heaters to simulate power load up to 97 W Cooling fluid at 5°C with 0.33 kg/min flow rate Calibrated infrared camera to monitor temperature: kept to 72°C

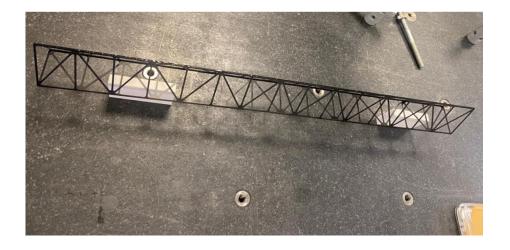


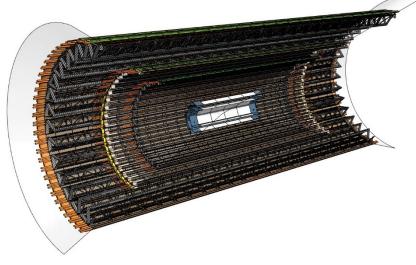
# WP10 Activities at INFN Cool FPGA (F. Bosi, F. Palla, Pisa)

Truss structure for outer layers of Belle 2 silicon tracker and future CEPC experiment

Measurements, simulations on prototypes and complete engineered design









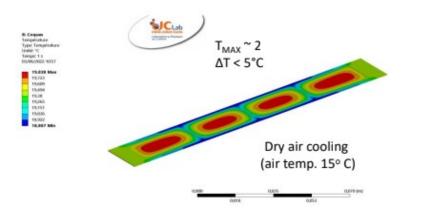
# WP10 Activities at CSIC (C. Mariñas, IFIC, M. Ullan CNM)

Thin multi-CMOS-chip Silicon structures for Belle 2 upgrade

Thermo-mechanical iVTX demonstrator delivered by IZM to Valencia/Bonn

Thermal simulations (IJCLab Paris) to be validated against lab tests

Basis for FE analysis of future collider cooling strategies (C. Orero, IFIC)



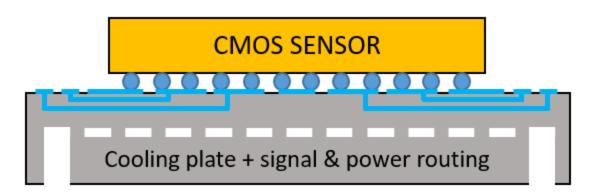


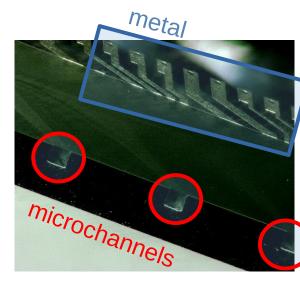


# WP10 Activities at CSIC (C. Mariñas, IFIC, M. Ullan CNM)

# Micro-channel production capacity at CNM

- Integrated cooling channels and metal system with different bonding techniques
  - Pre-processing (i.e. micro-channels first, metal/CMOS last)
  - Anodic (glass-Silicon) bonding post-processing
  - Optimizing eutectic wafer bonding technique





Wire bonding tests show integrity of metal after wafer bonding

### Steps on the way to CMOS-compatible integrated microchannels



# WP10 Activities at MPG-HLL (L. Andricek)

### MPG HLL Status



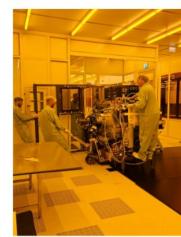
- ▷ MPG HLL is working on the installation of a process line for
  - → Post processing of up to 200 mm CMOS wafers
  - → Fabrication of actively cooled interposers with micro-channels and TSVs
  - → Low temperature direct bonding
  - → Hybrid bonding of post-processed CMOS wafers or single CMOS chips to sensors wafers

#### ▷ Current status

- → The clean room of MPG HLL was relocated to a new and larger building
- → Tests with equipment manufacturer finished, tool configuration done, purchasing in progress
- → Relocated equipment currently in the hook-up phase, qualification to follow











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Time line: building ready, new equipment available autumn 2024. Plasma-based direct bonding process defined, expected in 2025.





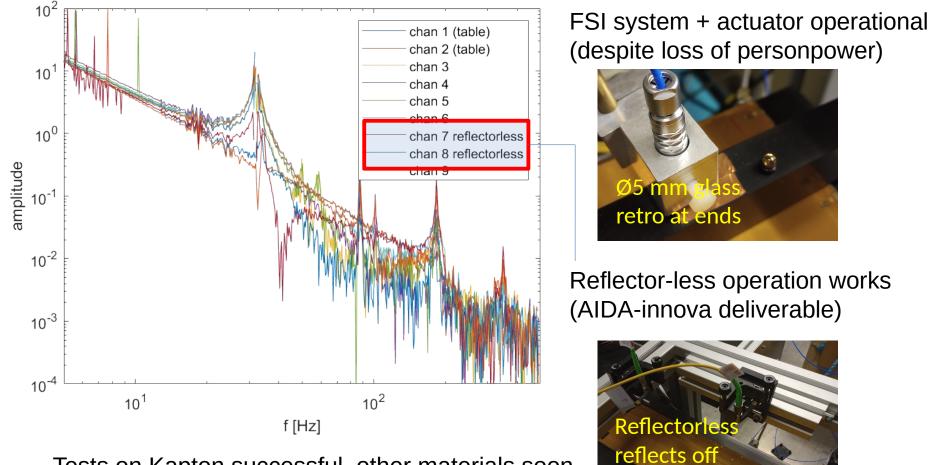




## WP10 Activities at Oxford (G. Viehhauser)

apton surface

### **Detailed characterization of mechanical response of tracker elements**



Tests on Kapton successful, other materials soon



### Status of WP10: reporting

D #	Deliverable Name	Lead beneficiary	Туре	Due Date (in months)
D10.1	Cooling device demonstrators	30 - CSIC	Report	46
D10.2	Hydraulic interconnection technologies	8 - CNRS	Report	43
D10.3	Supercritical CO2 as a refrigerant	25 - NTNU	Report	44
D10.4	Upgraded FSI	41 - UOXF	Report	45

Discussed also "lessons learnt" document on 3D printing with nonstandard materials

### Deliverables include reports on main tasks, Due in months 43-46 (end '24, early '25)



# WP10 – summary

### **Progress/results:**

Work proceeding correctly in most nodes; a selection of results shown today Important: industrial partners actively involved in developments

### Practical/organizational:

- Some synergy with I.FAST on additive manufacturing
- Massimo Angeletti joined (busy) WP10 conveners
- An extension of AIDAinnova is likely helpful in several areas